

VIA EFS

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In Re Patent Application of: §
Takashi ITO, et al. §
§
Conf. No.: 8148 § Group Art Unit: 1795
§
Appln. No.: 10/562,098 § Examiner: Anca Eoff
§
Filing Date: December 21, 2005 § Attorney Docket No.: 9369-114US
§ (T37-196236C)
Title: ACTINIC RADIATION -CURABLE STEREOLITHOGRAPHIC RESIN COMPOSITION
HAVING IMPROVED STABILITY

PETITION FOR EXTENSION OF TIME UNDER (37 C.F.R. § 1.136(a))

Applicant(s) in the above-identified application hereby petition(s) for a two-month extension of time to and including July 14, 2008 for responding to the Office Action mailed February 14, 2008. An Amendment accompanies this Petition.

A check in the amount of \$ _____.00 is enclosed herewith.
 The Commissioner is hereby authorized to charge Deposit Account No. 50-1017 (**Billing No. 209369.0114**) as noted below.
 Extension fee in the amount of \$460.00
 Any deficiencies or overpayments in the above-calculated fee.

Respectfully submitted,
Takashi Ito, et al.

July 14, 2008 _____ By: /Sandra M. Katz/
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